JUN 1 2 2002

Attorney's Docket No.: 12732-038001 / US4917/4945

N THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Hideomi Suzawa et al.

Art Unit : 2812

Serial No.: 09/852,672

Examiner: Viktor Simkovic

Filed

: May 11, 2001

Title :

: SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF

Commissioner for Patents Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Applicants submit the references listed on the attached form PTO-1449, copies of which are enclosed.

This statement is being filed after a first Office action on the merits, but before receipt of a final Office action or a Notice of Allowance. A check for \$180 in payment of the late submission fee of \$1.17(p) is enclosed. Please apply any other charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: June 12, 2002

John F. Hayden Reg. No. 37,640

Fish & Richardson P.C. 1425 K Street, N.W.

11th Floor

Washington, DC 20005-3500 Telephone: (202) 783-5070 Facsimile: (202) 783-2331

40094087.doc

06/17/2002 HVUONG1 00000017 09852672

01 FC:126

180.00 OP



		II	7462
			DALINE
Sheet	1		0/44/1

Substitute Fo	orm PT 449
(Modified)	×4,

Attorney's Docket No. 12732-038001

Application No. 09/852,672

Form PT 0449

U.S. Department of Commerce
Patent and Trademark Office

Information Disclosure Statement **by Applicant** (Use several sheets if necessary)

Applicant Hideomi Suzawa et al.

May 11, 2001

Filing Date

Group Art Unit 2812

(37 CFR §1.98(b))

U.S. Patent Documents							
Examiner Initial	Desig. ID	Patent Number	Issue Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	6,031,290	02/29/2000	Miyazaki et al.			03/13/1998
	AB						
	AC						
	AD						
	AE						
	AF						
	AG				-		
	AH						
	AI						
	AJ						
	AK						

Foreign Patent Documents or Published Foreign Patent Applications								
Examiner	Desig.	Document	Publication	Country or			Trans	lation
Initial	ID	Number	Date	Patent Office	Class	Subclass	Yes	No
	AL	6-148685	05/27/1994	Japan			Abs	
	AM	7-235680	09/05/1995	Japan			Abs	
	AN	8-274336	10/18/1996	Japan			Abs	
	AO							
	AP							

Other Documents (include Author, Title, Date, and Place of Publication)				
Examiner	Desig.			
Initial	ID	Document		
	AQ			
	AR			
	AS			
	AT			

Examiner Signature	Date Considered
Zanamar organization	

EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.